



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LEE, Ho  
Assignee: Samsung Electronics Co., Ltd.  
Title: CHEMICAL VAPOR DEPOSITION APPARATUS  
Application No.: 10/750,023 Filing Date: December 31, 2003  
Examiner: Jeffrie Robert Lund Group Art Unit: 1763  
Docket No.: AB-1350 US Confirmation No.: 9344

San Jose, California  
July 20, 2006

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


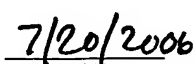
**PETITION FOR EXTENSION OF TIME**

Dear Sir:

Applicants respectfully petitions for a one-month extension of time within which to file the Response to the Office Action mailed on March 23, 2006 thus allowing the undersigned until July 20, 2006 to file a Response.

Please charge the amount of \$120.00 set forth in the enclosed transmittal letter.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 20, 2006.

  
Attorney for Applicant(s)   
Date of Signature

Respectfully submitted,



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